

<b>Notice of References Cited</b>	Application/Control No. 10/803,223	Applicant(s)/Patent Under Reexamination KITAGAWA, HITOSHI	
	Examiner Audrey Y. Chang	Art Unit 2872	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-			
	B	US-			
	C	US-			
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**FOREIGN PATENT DOCUMENTS**

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**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	"Temperature stability of thin-film narrow bandpass filters produced by ion-assisted deposition" by Takashashi, Applied Optics, Vol. 34, No. 4 pages 667-675.
	V	
	W	
	X	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
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